



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 7129

SERIAL NUMBER 10/727,449	FILING DATE 12/04/2003 RULE	CLASS 438	GROUP ART UNIT 2818	ATTORNEY DOCKET NO. 7403
-----------------------------	---------------------------------------	--------------	------------------------	--------------------------------

APPLICANTS

William Andrew Nevin, Partadown, IRELAND;

Paul Damien McCann, Jordanstown, IRELAND;

** CONTINUING DATA

***** NONE PD *****

** FOREIGN APPLICATIONS

***** NONE PD *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 08/10/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged <i>Langshaw</i> Examiner's Signature Initials	IRELAND	6	49	3

ADDRESS

Matthew E. Connors
 Gauthier & Connors LLP
 Suite 3300
 225 Franklin Street
 Boston, MA
 02110

TITLE

Method for forming a cavity and an SOI in a semiconductor substrate, and a semiconductor substrate having a buried cavity and/or an SOI formed therein

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
RECEIVED		